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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2895
Examiner: Swapneel CHHAYA

In Re PATENT APPLICATION of:

Applicant(s):	Takamitsu YAMANAKA)
U.S. Serial No.:	10/577,457)
U.S. Filing Date:	April 27, 2006)
International Serial No.:	PCT/JP2005/014208)
International Filing Date:	August 3, 2005) <u>AMENDMENT</u>
Priority Date Claimed:	August 17, 2004)
For:	SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD)
Attorney Reference:	AI 409NP)

March 24, 2009

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Action mailed on December 24, 2008, please amend the above-identified application as follows: